

Form PTO-1449

Docket Number (Optional)

Application Number

TSMC-00-488

10/791,014

Applicant

Chung-Shi Liu et al.

Filing Date

03/02/04

Group Art Unit

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

APR 5 2004

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
SW	6008120	12/28/99	Lee	438	634	12/1/98
	6103601	8/15/00	Lee et al.	438	513	6/10/99
	6121164	9/19/00	Yieh et al.	438	790	10/24/97
	6130157	10/19/00	Liu et al.	438	669	7/16/99
✓	6136680	10/24/00	Lai et al.	438	597	1/21/00
	6150272	11/21/00	Liu et al.	438	692	11/16/98

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portmanteau Pages, Etc.)

EXAMINER

DATE CONSIDERED

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